IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	
TAKESHI ICHIKAWA ET AL.	: Examiner: Christopher M Raabe
Application No.: 10/516,545	: Art Unit: 2879
Filed: December 2, 2004	: Conf. No.: 2864
For: ELECTRON-EMITTING DEVICE AND MANUFACTURING METHOD THEREOF) November 2, 2007

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Sir:

Preliminary to examination, the Examiner is respectfully requested to amend the above-identified application as follows, the specification changes being indicated at page 2, the claims being listed beginning at page 3, and the Remarks appearing at page 12: